

10/15/2004 16:37 FAX 5124918918

## MOLECULAR IMPRINTS

RECEIVED  
CENTRAL FAX CENTER

OCT 15 2004

1

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Choi et al.

**PATENT APPLICATION**

Serial No.: 09/698,317

Group Art Unit: 2834

Filed: Oct. 27, 2000

Examiner: Dougherty, Thomas M.

For: HIGH PRECISION ORIENTATION ALIGNMENT AND GAP CONTROL  
STAGES FOR IMPRINT LITHOGRAPHY PROCESSES

### AMENDMENT AFTER NOTICE OF ALLOWANCE

Commissioner  
for Patents  
Alexandria, VA 22313

Sir:

In response to the Notice of Allowance mailed

September 1, 2004, please amend the application as follows:

///

////

///

////

///

///

////

////

111-1

///

////

////

////

////

////

////

////

///

////

////

PAGE 31/3 \* RCVD AT 10/15/2004 5:35:37 PM [Eastern Daylight Time] \* SVR:USPTO-EFXRF-1/2 \* DNIS:8729306 \* CSID:5124918918 \* DURATION (mm:ss):03:28